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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of: **TANIGUCHI, Osamu et al.**

Group Art Unit: 2823

Serial No.: 10/084,923 ✓

Examiner: **William M. BREWSTER**

Filed: **March 1, 2002** ✓

P.T.O. Confirmation No.: 7126

**FOR: THIN-FILM CIRCUIT SUBSTRATE AND MANUFACTURING METHOD
THEREOF, AND A VIA FORMED SUBSTRATE AND MANUFACTURING METHOD
THEREOF**

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, D.C. 20231

Date: April 4, 2003

Sir:

This paper is submitted in response to the Official Action dated **March 21, 2003**.

In the Action, restriction is required between Group (I), Claims 1-10 and 17-22; and
Group (II), Claims 11-16 and 23-29.

Applicants hereby elect the subject matter of Group (I), Claims 1-10 and 17-22 for
prosecution in this application. This election is made without traverse, it being understood that
the applicants' rights to the filing of a divisional application directed to the non-elected subject
matter under 35 USC 120 and 35 USC 121 are retained.

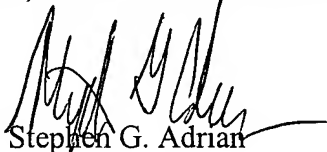
In the event that this paper is not timely filed, applicants hereby petition for an
appropriate extension of time. The fee for any such extension may be charged to our Deposit
Account No. 01-2340.

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In the event any additional fees are required in connection with this response, please
charge our Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE